## Analytical SEM Solutions for Geology

Exploring Microstructure and Chemistry in Minerals using EBSD and CL



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### Presenters



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### Analytical SEM Solutions for Geology Overview of part 2



#### I – Cathodoluminescence for Geology

- CL process in rocks
- CL imaging of minerals

#### **II – Advanced EBSD solution of mineralogical samples**

- EBSD technique review
- Phase ID and discrimination with simultaneous EBSD/EDS measurement
- Advanced imaging with built-in ARGUS system

#### **III** – Sample preparation of minerals

- Broad Ion Beam Milling vs mechanical polishing
- Application examples

#### Q&A

### Analytical SEM Solutions for Geology Part II



1 - Cathodoluminescence imaging for geology

# Cathodoluminescence imaging for geology



## Electron beam excitation and light







### Cathodoluminescence process in rocks



For a crystalline material, electrons in that material can only occupy certain energy states. Typically, (almost) all electrons reside in the valence band

- Rocks are typically insulators with wide band gaps between 5 - 15 eV (DUV-EUV)
- In CL we measure in the 0.8 6 eV range
- Defect states play an important role

# delmic

# Defect emission in CL





## SPARC Cathodoluminescence system



# CL imaging modes

CL intensity mapping

- Measure CL intensity
- Short dwell times (10 100 µs) → video-rate imaging
- Coarse spectral filtering and RGB mapping



- Measure CL spectrum
- Longer dwell times (10 1000 ms)
- Hyperspectral imaging with high spectral resolution



## CL systems

Jolt



Basic system for (RGB) intensity CL mapping



SPARC Compact

Compact CL system for high-performance (RGB) intensity CL mapping

SPARC Spectral



High-performance intensity mapping and spectroscopy



## CL on quartz sandstone





T. Coenen, whitepaper (2016) <sup>12</sup>





Combine CL and SEM data to reveal interesting sample features



### Microcharacterization of Zircons: Imaging zonation





## Zircon spectroscopy





- Map spectral distribution over large crystal
- Observe spectral differences between bands
- REE and intrinsic defect emission



Sample: Dr. Changfu Fan (Beijing Geonanalysis Co Ltd)

delmic

## Zircon spectroscopy



- Identify different REE species based on 4f transition energies
- Very high sensitivity down to 10<sup>14</sup> atoms/cm<sup>3</sup>

- Carbonate
- > Apatite
- > Monazite



## Sapphires



## Conclusions

- CL presents a fast and powerful technique for microanalysis of rocks
- With current sensitivity and precision novel applications are within reach
- New CL approaches and techniques can broaden scope









### Analytical SEM Solutions for Geology Part II



## 2 – Advanced EBSD solution for geology

Advanced characterization of mineralogical samples outline



- EBSD setup
- Combined EBSD/EDS measurement
  - Advanced Phase Identification
  - Phase discrimination by EDS
- Advanced imaging with built-in ARGUS system
- Summary

### Introduction Experimental setup





### Introduction Combined EBSD/EDS measurement





### Software features:

• One software platform to control both detectors and to perform all types of analysis possible

• Simultaneous EBSD/EDS acquisition of EBSP and full EDS spectrum

•Online/offline phase ID and discrimination between phases creating similar patterns

### Hardware features:

Unique detector features for allowing data acquisition in optimized conditions:

- In-situ EBSD detector tilt
- VZ-adapter for EDS detector tilt

### Introduction Measurement at short WD





### Introduction Measurement at long WD





Advanced characterization of mineralogical samples outline



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### Phase identification



#### **Conventional phase ID >** *before launching measurement* **keeps SEM busy**

- time consuming manual setup
- inaccurate:

based on BSE image – can miss phases

using manually defined threshold – not best fitting phases

#### Advanced phase ID > offline after measurement, SEM is free

- interactive (phase search, band detection, etc.)
- fast and automatic phase identification over thousands of candidates
- best fitting phase file is selected
- ultra fast reanalysis (>40 000 pps)

### Advanced phase ID Setup





Sample: oceanic gabbro from IODP 304/305 Measurement type: Simultaneous EBSD/EDS EBSP resolution: 160x120 pixels Map size: 1000x750 points Pixel size: 1.66 microns

Acknowledgments to: Dr. Angela Halfpenny\* Dr. Michael Verrall CSIRO, Perth, Australia \*now at Central Washington University, WA, US





- Advanced phase ID: (Online)
- Acquire EDS spectrum and EBSP on selected point









- Advanced phase ID: (Online)
- 1. Acquire EDS spectrum and EBSP
- Search in database for candidate phases (Fe, O) – 289 entries
- Automatic/interactive band detection





- Advanced phase ID: (Online)
- 1. Acquire EDS spectrum and EBSP
- Search in database for candidate phases (Fe, O) – 289 entries
- Automatic/interactive band detection
- Software tries all 289 entries in ~10 sec
- Solutions are classified based on quality of fit
- Best fitting phase file added to phase list
- System ready for acquiring data





Advanced phase ID: (Offline) After data EBSD/EDS acquisition, repeat the same advanced phase ID procedure with the missing phases:

- Select one point from the map
- 2. Perform advanced phase ID





Advanced phase ID: (Offline) After data EBSD/EDS acquisition, repeat the same advanced phase ID procedure with the missing phases:

- Select one point from the map
- 2. Perform advanced phase ID
- 3. Ilmenite: SG 148
- 4. Reindex map in 50 sec





- Advanced phase ID: (Offline)
- 1. Magnetite: SG 227
- 2. Ilmenite: SG 148
- Repeat procedure for the other unknown phases...





#### Final EBSD data:

- 1. Magnetite: SG 227
- 2. Ilmenite: SG 148
- 3. Pyrrhotite: SG 194
- 4. Apatite: SG 176
- 5. Quartz: SG 152
- 6. Augite: SG 15
- 7. Anorthite (Na): SG 2
- 8. Hastingsite: SG 12
- 9. Clinohypersthene: SG 14
- 10. Clinochlore: SG 5
Advanced characterization of mineralogical samples outline



- EBSD setup
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# Phase discrimination by EDS EBSD only





# Phase discrimination by EDS with EDS quantification assistance





### Mylonitic Iherzolite (Lers, France) EBSD Phase map





EBSD Phase map Hit rate 85 % Olivine Opx Cpx Spinel

Plagioclase!



### Calcium carbonates Phase discrimination with EBSD/EDS





EBSD can distinguish chemically identical phases such as calcite and aragonite

### Investigating thermomechanical processes Mafic boudins in granulite facies Lindas Nappe, SW Norway





Sample courtesy and study: Dr. D.Spengler, Stuttgart University, Germany

### Investigating thermomechanical processes EDS mixed element map





### Investigating thermomechanical processes EDS Autophase





### Investigating thermomechanical processes EBSD Phase map





EBSD Phase map

Magnetite Ilmenite K-Feldpsar Plagioclase Garnet CPX OPX Amphibole

### Investigating thermomechanical processes Strain localisation map on garnet





Misorientation map porphyroclastic garnet



### EBSD/EDS analysis on metals and minerals: CB carbonaceous chondrite Gujba 3D µ-XRF, 3D EDS & EBSD





# EBSD analysis of impactite example on shocked quartz



Shocked quartz in impactite (Yaxcopoil sample)



SE image of ballen quartz



Orientation contrast image (FSE)

# EBSD analysis of impactite example on shocked quartz



Shocked quartz in impactite (Yaxcopoil sample)



# EBSD analysis of impactite example on shocked quartz



Shocked quartz in impactite (Yaxcopoil sample)



# Advanced characterization of mineralogical samples outline



- EBSD setup
- Combined EBSD/EDS measurement
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### FSE/BSE imaging system How does it work?



- ARGUS is a **build-in** BSE & FSE detector: no loss of signal, high signal/noise ratio
- Each diode captures a similar amount of noisy backscattered electrons and a different part of the diffracted backscattered electrons, i.e. EBSD signal.
- Signal (e<sup>-</sup> counts) is transferred using a separate channel for each diode. A color is assigned to each diode.
- When scanning, for each pixel the system will obtain three numbers which will be transformed into three RGB levels.
- Then the three signals/RGB levels are mixed



Following slides are examples of colour-coded FSE images on minerals

### Color-coded orientation contrast Tectonically deformed Quartz





## Color-coded orientation contrast

C-coated sample (quartz) and low vacuum mode examples







### Grayscale orientation contrast Protomylonitic Iherzolite





### Color-coded orientation contrast Protomylonitic Iherzolite





### Color-coded orientation contrast Protomylonitic Iherzolite





### Color-coded orientation contrast Protomylonitic Iherzolite – zoom on ultrafine grains





# Colour-coded orientation imaging shocked minerals - Quartz





grayscale orientation contrast imaging vs color-coded

Advanced characterization of mineralogical samples Summary



- Unique hardware features
  - EBSD & EDS detector tilt and "slim" design for better data
  - built-in ARGUS<sup>™</sup> FSE/BSE imaging system
  - Optimized EBSD/EDS integration
    - Advanced phase ID offline & online
    - Phase discrimination by EDS quantification assistance during EBSD re-indexing
- Ultrafast re-indexing (optimizing SEM time)

### Analytical SEM Solutions for Geology Part II



### Chapter 3 – Sample preparation for SEM & EBSD





## Advanced Sample Preparation for SEM & EBSD

*Sten Sturefelt, Hitachi High-Technologies Webinar, 10<sup>th</sup> of September 2019* 

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Advanced Sample preparation for SEM & EBSD



## **Broad Ion Beam Milling**

Creating a clean and flat sample surface for SEM and EBSD studies



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*Cut into proper size, polished with grinding paper or paste* 

# Is it ready for high resolution studies?





### **Damages from Cutting and Polishing**



#### Hitachi High-Tech

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#### **Damages from Polishing - Example**



Steel polished with 9 µm diamond

Hitachi High-Tech



#### **Damages from Polishing - Example**



Steel polished with 3 µm diamond

Hitachi High-Tech



#### **Damages from Polishing - Example**



Steel polished with 1 µm diamond

Hitachi High-Tech

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**Broad Ion Beam Milling (BIB)** 



### BIB ≠ FIB

Ablation via momentum transfer from Argon lons



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### **Broad Ion Beam Milling – Reasons Why**

- Traditional polishing or cutting techniques of hard or ductile, soft and composite materials introduce significant lateral sheer forces
- The result is scratches, smearing, delamination or other damage
- Ion Milling eliminates oxide films or contamination and will enhance crystal orientation contrast
- Ion Milling removes artifacts resulting in a smooth, polished surface ideal for EDX and EBSD analysis
- Prepare a "stress-free" cross-section of complex compound materials





#### **Broad Ion Beam Milling – Flat Milling & Cross-sections**



Hitachi IM4000+

### Hitachi IM5000 (ArBlade)

#### Hitachi High-Tech







Flat Milling Set-up

### Cross-section Set-up

#### Hitachi High-Tech

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#### Advanced Sample preparation for SEM & EBSD HITACHI Inspire the Next

## Ion Milling of Flat Surfaces



Hitachi High-Tech



Flat milling method: Shifts the beam over the surface to uniformly sputteretch the sample with Argon ions

## The milling angle strongly influences the result





Angles >15° ⇒ Selective etching (chemistry, orientation)





Steel polished with 1 um diamond. Ion polished at 60 degrees at 6 kV during 10 minutes.

HITACHI



Angles >15° ⇒ Selective etching (chemistry, orientation)

Angles <10° ⇒ Reduces topography





Steel polished with 1 um diamond. Ion polished at 10 degrees at 6 kV during 10 minutes.

HITACHI



## **Flat Milling - Geological Application**



Pegmatit after Flat Milling

Sample courtesy of Prof. Claudia Trepmann, Ludwig Maximilian University, Munich

## Ion Beam Milling and Incidents Angles – Cross-sections



Hitachi High-Tech

Angles >15° ⇒ Selective etching (chemistry, orientation)

Angles <10° ⇒ Reduces topography

At 0° using a mask ⇒ Cross-section

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#### Advanced Sample preparation for SEM & EBSD HITACHI Inspire the Next

### **Ion Milling Cross-sections**





Cross-section Milling: Sputter-etch the sample with Ar ions partly covered with a mask to gradually produce a sharp edge

#### Advanced Sample preparation for SEM & EBSD HITACHI Inspire the Next

## **Ion Milling Cross-sections**





Resin embedding can be omitted, carbon glue can be used instead. No pre-polishing needed.

Advanced Sample preparation for SEM & EBSD



## Ion milled section





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Porous Zirkonium shell with active catalyst particle Milling condition: Ion beam voltage 6 kV, time 1-2 hours

## Hitachi High-Tech

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## **Ion Milling Cross-sections – Application Example**



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**Inspire the Next** 



## **Ion Milling Cross-sections – Application Example**



Shell from the North Sea (calcite)

## **EBSD** of biominerals without coating





## Right: diffraction band contrast image and IPF Y map (calcite)



## Summary

- Broad Ion Beam (BIB) Milling is ideal for creating a flat and smooth sample surface for both EDX and EBSD analysis in high resolution.
- BIB also eliminates oxide films or contamination and will enhance crystal orientation contrast.
- BIB can be used on hard, soft and composite materials.
- Flat Milling is a quick method for embedded samples and can be adjusted for selective etching.
- Cross-section Milling is ideal for flat samples and thin layer studies. No resin embedding or pre-polishing needed.





## **Are There Any Questions?**

Please type in the questions you might have in the Q&A box and press *Send*. More Information



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